

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Chang Seo Park et al.	Docket No.:	061472-0308425
Serial No.:	10/826,665	Group Art Unit:	2813
Filing Date:	April 16, 2004	Examiner:	Harrison, Monica D.
For:	A METHOD TO FABRICATE CMOS DEVICE WITH DUAL METAL GATE ELECTRODES		

OFFICE ACTION RESPONSE

MAIL STOP AMENDMENT
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is filed in response to the Office Action dated March 22, 2006.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.